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**INFORMATION DISCLOSURE STATEMENT
 BY APPLICANT**

Applicant: Heine M. MULDER *et al.*

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Examiner: ~~Unknown~~ R. Fuller Group Art Unit: ~~Unknown~~ 2851

Date: October 15, 2003 Page 1 of 1

U.S. PATENT DOCUMENTS

Examiner's Initials*	Document Number	Date MM/YYYY	Name (Family Name of First Inventor)	Class	Sub Class	Filing Date (if appropriate)
	AR					
	BR					
	CR					
	DR					
	ER					
	FR					
	GR					
	HR					
	IR					
	JR					
	KR					
	LR					
	MR					
	NR					

FOREIGN PATENT DOCUMENTS

	Document Number	Date MM/YYYY	Country	Inventor Name	English Abstract	Translation Readily Available
					Enclosed	No
	OR					
	PR					
	QR					
	RR					
	SR					
	TR					
	UR					
	VR					
	WR					
	XR					

OTHER (Including in this order Author, Title, Periodical Name, Date, Pertinent Pages, etc.)

R7	YR	Joseph P. Kirk, "Scattered Light in Photolithographic Lenses", Optical/Laser Microlithography VII (1994), SPIE Vol. 2197, pgs. 566-572			
	ZR				
	AAR				
	BBR				

Examiner: R. Fuller Date Considered: 10-6-04

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.